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10/593,141	07/25/2007	Gerald Meinhardt	5367-264PUS	8752
27799 COHEN, PONTANI, LIEBERMAN & PAVANE LLP 551 FIFTH AVENUE			EXAM	IINER
			LINDSAY JR, WALTER LEE	
SUITE 1210 NEW YORK, I	NY 10176		ART UNIT	PAPER NUMBER
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary

Application No.	Applicant(s)	Applicant(s)	
10/593,141	MEINHARDT ET AL.		
Examiner	Art Unit		
Walter L. Lindsay, Jr.	2812		

	Examiner	AILOIIL				
	Walter L. Lindsay, Jr.	2812				
The MAILING DATE of this communication app	ears on the cover sheet with the c	orrespondence ac	ldress			
Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (9) MCPIT's from the mailing date of the communication. - Failur to reply within the act or extended period for reply will by statute. Any reply received by the Office later than three months after the mailing earned patent form adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 16(a). In no event, however, may a reply be tin till apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	I. lely filed the mailing date of this of (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on						
- ' - '						
3) Since this application is in condition for allowar	☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merit					
closed in accordance with the practice under E	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4) Claim(s) 16-29 is/are pending in the application	,					
	4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.	m nom consideration.					
6)⊠ Claim(s) <u>16-29</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/or	election requirement.					
,,						
Application Papers						
9)☐ The specification is objected to by the Examine						
10) The drawing(s) filed on is/are: a) acce						
Applicant may not request that any objection to the						
Replacement drawing sheet(s) including the correct						
11)☐ The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form P	ГО-152.			
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:	priority under 35 U.S.C. § 119(a)	-(d) or (f).				
 Certified copies of the priority documents 	 Certified copies of the priority documents have been received. 					
Certified copies of the priority documents	s have been received in Applicati	on No				
Copies of the certified copies of the prior	ity documents have been receive	ed in this National	Stage			
application from the International Bureau	(PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list	of the certified copies not receive	d.				
Attachment(s)						
1) Notice of References Cited (PTO-892)	Interview Summary Paper No(a) Mail Do					

Attachment(s)		
Notice of References Cited (PTO-892)	4) Interview Summary (PTO-413)	
Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Date	
3) Information Disclosure Statement(s) (PTO/SE/08)	 Notice of Informal Patent Application 	
Paper No/e)/Mail Date	6) Other:	

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DETAILED ACTION

This Office Action is in response to an Amendment filed 12/08/2008.

Currently, claims 16-29 are pending. Claims 1-15 have been cancelled.

Claim Rejections - 35 USC § 102

 The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- Claims 16-21, 23, 24, 26 and 28 are rejected under 35 U.S.C. 102(b) as being anticipated by Johansson et al. (US 6.440,810 B1).

Regarding claim **16**, Johansson et al. discloses a method for the production of a bipolar transistor comprising a highly doped extrinsic base, wherein the method comprises the steps of: (col. 2, line 65-col. 3, line 10) providing a base layer(5) on a semiconductor substrate(1) (Fig. 2, col. 3, line 60); depositing a dielectric layer(7) in weakly doped or undoped fashion on the base layer (Fig. 3, col. 4, lines 11-16); applying an implantation mask (13) and patterning in such a way that an opening remains in a region provided for a later extrinsic base (Fig. 7, col. 4, lines 41-43); introducing BF_2 as a dopant of a first conductivity type into the dielectric layer after the application of the mask; indifusing, in a controlled thermal step, the dopant into the semiconductor substrate from the dielectric layer, an extrinsic base doped in low-resistance fashion arising (Fig. 5, col. 4, lines 25-34).

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Regarding claim 17, Johansson et al. discloses a method in which an oxide layer is deposited as the dielectric layer(5) (DS) (col. 4, lines 11-14).

Regarding claim 18, Johansson et al. discloses a method in which an emitter window(15) is opened in the dielectric layer(5) (Fig. 7, col. 4, lines 41-43).

Regarding claim 19, Johansson et al. discloses a method in which before the dopant is introduced into the dielectric layer, the emitter is produced by application and patterning of a polycrystalline emitter layer doped with a dopant of the second conductivity type above the emitter window (col. 5, lines 2-15).

Regarding claim 20, Johansson et al. discloses a method in which the emitter layer is patterned by means of a photopatterned resist mask(13) that remains on the emitter and is later used as an implantation mask for the implantation of the dopant into the dielectric layer(5) (Fig. 8, col. 4, lines 41-59).

Regarding claim 21, Johansson et al. discloses a method in which, for the production of the semiconductor substrate(1), in a semiconductor wafer doped with a dopant of the second conductivity type, active transistor regions are defined and are electrically insulated by oxide regions; and (Fig. 1, col. 3, lines 47-56) in which a base layer weakly doped with a dopant of the first conductivity type is grown epitaxially over the whole area (Fig. 2, col. 3, lines 60-66).

Regarding claim **23**, Johansson et al. discloses a method in which BF.sub.2 is implanted for the introduction of the dopant into the dielectric layer (Fig. 5, col. 4, lines 25-28).

Regarding claim **24**, Johansson et al. discloses a method in which BF₂ can be indiffused into the dielectric layer from the gas phase (Fig. 5, col. 4, lines 25-29).

Regarding claim **26**, Johansson et al. discloses a method in which the dielectric layer is removed after the patterning of the emitter layer and after the outdiffusion of the dopant in uncovered regions by etching (col. 5, lines 11-14).

Regarding claim **28**, Johansson et al. discloses a method in which a photomask(13) applied over an oxide layer over the emitter is used as the implantation mask, said photomask already having been used beforehand for the patterning of the emitter layer (Fig. 7, col. 4, lines 41-43).

Claim Rejections - 35 USC § 103

- The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:
 - Determining the scope and contents of the prior art.
 - Ascertaining the differences between the prior art and the claims at issue.
 - Resolving the level of ordinary skill in the pertinent art.
 - Considering objective evidence present in the application indicating obviousness or nonobviousness.

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 Claims 22, 25, 27 and 29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Johansson et al. (US 6,40,810 B1) in view of Johnson (6,028,345).

Johansson et al. discloses the method substantially as claimed. See the preceding rejection of claims 16-21, 23, 24, 26 and 28 under 35 U.S.C. 102(b).

However, Johansson et al. fails to show that a buried collector layer is doped with a dopant of the second conductivity type, the doping of the emitter layer, and the production of metallic contacts.

Regarding claim 22, Johnson discloses a method in which a buried collector layer(102) doped with a dopant of the second conductivity type is produced by implantation in the semiconductor wafer in the active transistor region(100), said collector layer serving for electrical connection of the collector (Fig. 3, col. 3, lines 40-46).

Regarding claim 25, Johnson discloses a method in which the emitter layer is doped with arsenic, in which, during the indiffusion of the dopant into the base layer (BS)(110), arsenic also indiffuses into a surface region of the base layer (BS) from the emitter (E)(130) (Fig. 4, col. 3, line 63-col. 4, line 7).

Regarding claim 27, Johansson et al. discloses a method further comprising the steps of: providing an n-doped semiconductor (Fig. 1, col. 3, lines 47-53); growing a p-doped base layer(5) epitaxially on the semiconductor wafer(1) over the whole area (Fig. 2, col. 3, lines 60-64); applying a dielectric layer(7) in weakly doped or undoped fashion on the base layer; opening an emitter window(15) in the dielectric layer (col. 4, lines 11-14); producing the emitter by application and patterning of an As-doped polycrystalline

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emitter layer above the emitter window (Fig. 9, col. 4, lines 53-59, 64-65); introducing BF_2 as the dopant into the dielectric layer with the aid of an implantation mask (Fig. 5, col. 4, lines 25-28).

Johnson discloses method in which in a controlled thermal step, indiffusing boron from the dielectric layer into the base layer in the region of the extrinsic base, the latter acquiring low resistance, and simultaneously indiffusing arsenic into an upper region of the base layer from the emitter through the emitter window (Fig. 4, col. 3, line 47-col. 4, line 7).

Regarding claim 29, Johnson et al. discloses a method in which the collector connection is effected via an n⁺-doped buried layer, and in which, over the emitter and in the region of the extrinsic base, the respective semiconductor is uncovered and metallic contacts(150) are produced above the latter (Fig. 8a-d, col. 4, lines 22-46). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to combine the teachings of Johnson with the method of Johansson et al. to form a bipolar transistor that includes a collector region comprising a buried collector and doped epitaxial layer (col. 2, lines 53-61).

Response to Arguments

Applicant's arguments filed on 12/08/2008 have been fully considered but they
are not persuasive. The examiner upon further inspection does not see a difference
between what is claimed and the prior art, the opening disclosed in the prior art

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reference and the claimed invention are in the same position, and undergo the same process of doping and diffusion. Further clarification is encouraged.

Conclusion

 Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, THIS ACTION IS MADE FINAL. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Walter L. Lindsay, Jr. whose telephone number is (571) 272-1674. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Charles Garber can be reached on (571) 272-2194. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Walter L. Lindsay, Jr./ Primary Examiner, Art Unit 2812

3/15/2009